	Application No.	Applicant(s)
Notice of Allowability	10/602,738	HATANO ET AL.
	Examiner	Art Unit
	Stanetta D. Isaac	2812
The MAILING DATE of this communication apperall claims being allowable, PROSECUTION ON THE MERITS IS therewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIP of the Office or upon petition by the applicant. See 37 CFR 1.313 1. This communication is responsive to 06/25/03. 2. The allowed claim(s) is/are 1-23.	ars on the cover sheet with the co (OR REMAINS) CLOSED in this app or other appropriate communication GHTS. This application is subject to and MPEP 1308.	orrespondence address olication. If not included will be mailed in due course. THIS
 She drawings filed on 25 June 2003 are accepted by the E. Acknowledgment is made of a claim for foreign priority un All b) Some* c) None of the: 		
 Certified copies of the priority documents have 	been received.	
2. Certified copies of the priority documents have been received in Application No		
3. Copies of the certified copies of the priority documents have been received in this national stage application from the		
International Bureau (PCT Rule 17.2(a)).		
* Certified copies not received:		
5. Acknowledgment is made of a claim for domestic priority under 35 U.S.C. § 119(e) (to a provisional application) since a specific reference was included in the first sentence of the specification or in an Application Data Sheet. 37 CFR 1.78.		
(a) The translation of the foreign language provisional application has been received. 3. Acknowledgment is made of a claim for domestic priority under 35 U.S.C. §§ 120 and/or 121 since a specific reference was included		
in the first sentence of the specification or in an Application Data Sheet. 37 CFR 1.78.		
Applicant has THREE MONTHS FROM THE "MAILING DATE" of below. Failure to timely comply will result in ABANDONMENT of the complyment of the complex complyment.	this communication to file a reply co	emplying with the requirements noted
7. A SUBSTITUTE OATH OR DECLARATION must be submitted. Note the attached EXAMINER'S AMENDMENT or NOTICE OF INFORMAL PATENT APPLICATION (PTO-152) which gives reason(s) why the oath or declaration is deficient.		
B. CORRECTED DRAWINGS (as "replacement sheets") mus	t be submitted.	
(a) ☐ including changes required by the Notice of Draftspers1) ☐ hereto or 2) ☐ to Paper No	on's Patent Drawing Review (PTO-	948) attached
(b) including changes required by the proposed drawing co	orrection filed, which has be	en approved by the Examiner.
(c) Including changes required by the attached Examiner's Amendment / Comment or in the Office action of Paper No		
Identifying indicia such as the application number (see 37 CFR 1. each sheet. Replacement sheet(s) should be labeled as such in the	84(c)) should be written on the drawin ne margin according to 37 CFR 1.121(c	ngs in the front (not the back) of
9. DEPOSIT OF and/or INFORMATION about the deposit attached Examiner's comment regarding REQUIREMENT FOR T	sit of BIOLOGICAL MATERIAL m HE DEPOSIT OF BIOLOGICAL MA	nust be submitted. Note the TERIAL.
Attachment(s)		
I⊠ Notice of References Cited (PTO-892)	5 Notice of Informal Par	tent Application (PTO-152)
Notice of Draftperson's Patent Drawing Review (PTO-948) Information Disclosure Statements (PTO-1449 or PTO/SB/08), Paper No		PTO-413), Paper No
), 7⊠ Examiner's Amendme	ent/Comment
Faper No I Examiner's Comment Regarding Requirement for Deposit of Biological Material		t of Reasons for Allowance

DETAILED ACTION

EXAMINER'S AMENDMENT

1. An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

The application has been amended as follows: Claim 1 line 14, following interval modulated by scanning the laser beam delete—or and insert—on.

Allowable Subject Matter

- 2. Claims 1-23 are allowed.
- 3. The following is an examiner's statement of reasons for allowance: Applicant's independent claim 1 is allowed over the prior art of record because none teach or render obvious a method for fabricating an image display device comprising an active matrix substrate having a pixel region formed with a large number of pixels arranged as a matrix and a drive circuit region formed with an active circuit for supplying a drive signal to said pixels from outside said pixel region, the method comprising the steps of:
- 4. selectively irradiating a portion of the polycrystalline silicon film located in said drive circuit region with a laser beam having a pulse width and /or a pulse interval modulated by scanning the laser beam on the substrate to form discrete reformed regions each composed of a quasi-strip-like-crystal silicon film resulting from reformation, said quasi-strip-like-crystal silicon film having a crystal boundary continuous in the direction of scanning. See Voustas US Patent 6,664,147 where Voustas teaches a semiconductor method where a polycrystalline silicon

Application/Control Number: 10/602,738

Art Unit: 2812

film is formed having a crystal boundary continuous in the direction of scanning, however fails the step where the laser beam on the substrate to form discrete reformed regions each composed

Page 3

of a quasi-strip-like-crystal silicon film resulting form reformation.

5. All dependent claims are also rendered allowable.

6. Any comments considered necessary by applicant must be submitted no later than the

payment of the issue fee and, to avoid processing delays, should preferably accompany the issue

fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for

Allowance."

7. Any inquiry concerning this communication or earlier communications from the

examiner should be directed to Stanetta D. Isaac whose telephone number is 703-308-5871. The

examiner can normally be reached on Monday-Friday 7:30am -5:30pm.

8. If attempts to reach the examiner by telephone are unsuccessful, the examiner's

supervisor, John Niebling can be reached on 703-308-3325. The fax phone number for the

organization where this application or proceeding is assigned is 703-308-7722.

9. Any inquiry of a general nature or relating to the status of this application or proceeding

should be directed to the receptionist whose telephone number is 703-308-0956.

Stanetta Isaac Patent Examiner January 11, 2004

Supervisory Patent Examiner
Technology Center 2800